

Refine Search

Search Results -

Term	Documents
(6 AND 4).USPT,EPAB,JPAB,DWPI,TDBD.	76
(L4 AND L6).USPT,EPAB,JPAB,DWPI,TDBD.	76

Database:

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Search History

DATE: Thursday, February 19, 2004 [Printable Copy](#) [Create Case](#)

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DB=USPT,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ

<u>L1</u>	cmp or chemical mechanical polishing	31303	<u>L1</u>
<u>L2</u>	(magnesium or beryllium or calcium or strontium or barium or radium) with (oxide or hydroxide or sulfate or stearate or carbonate or salt)	384147	<u>L2</u>
<u>L3</u>	11 same L2	98	<u>L3</u>
<u>L4</u>	11 and L2	1211	<u>L4</u>
<u>L5</u>	polyurethane or poly urethane or polyurea or poly urea or polyolefin or poly. olefin or polyvinyl or poly vinyl or polycarbonate or poly carbonate or polyketone or poly ketone or polysulfone or poly sulfone or polyamide or poly amide or nylon or polypropylene or poly propylene or polyethylene or poly ethylene or polyvinylacetate or ethylene vinyl acetate	1306471	<u>L5</u>
<u>L6</u>	11 same L5	935	<u>L6</u>
<u>L7</u>	13 and L6	17	<u>L7</u>

L8 14 and L6

76 L8

END OF SEARCH HISTORY